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Calibration des leviers AFM

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AFM: measurement of cantilever's deflexion Δz

stiffness
$$k$$
 $F = k\Delta z$

 \rightarrow interaction force F between probe and sample

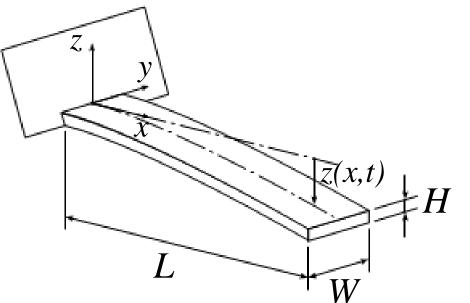
AFM force measurements requires calibration of cantilever's stiffness

Introduction

- 1. Theoretical stiffness from Euler Bernoulli model
 - > theoretical stiffness k_0 of the cantilever
 - \succ from k_0 to k : corrections due to position of the probe
- 2. Calibration using static deformations
 - cantilever against reference cantilever method
- 3. Calibrations based on modes of oscillation
 - simple harmonic oscillator method
 - Cleveland's added mass method
 - Hydrodynamic Sader method
 - Thermal noise calibration

Conclusion

Euler-Bernoulli model for a rectangular cantilever



 \blacktriangleright long beam: L >> T, H

- > small deformations : $L << \Delta z = z(L)$
- \succ constant Young modulus *E*
- constant rectangular section

Flexion only: z(x,t)

$$\frac{m_c}{L}\frac{\partial^2 z}{\partial t^2} + E\frac{WH^3}{12}\frac{\partial^4 z}{\partial x^4} = f_{ext}(x)$$

> constant linear mass where m_c is the cantilever mass external force / unit length

Static deformations in Euler-Bernoulli model Point *F* force at the end of the cantilever

Z.

$$E\frac{WH^{3}}{12}\frac{\partial^{4}z}{\partial x^{4}} = f_{ext}(x) = 0$$

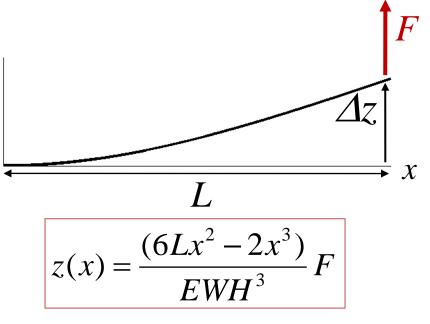
with boundary conditions

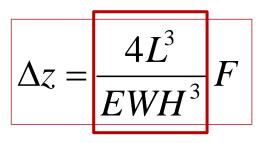
➤ at x = 0 : fixed position and angle

$$z(x=0) = \frac{\partial z}{\partial x}\Big|_{x=0} = 0$$

> at x = L: point force F + no torque

$$\frac{\partial^3 z}{\partial x^3}\Big|_L = -\frac{12}{EWH^3}F; \left.\frac{\partial^2 z}{\partial x^2}\right|_L = 0$$





 $1/k_0$

Static deformations in Euler-Bernoulli model Point *F* force at the end of the cantilever

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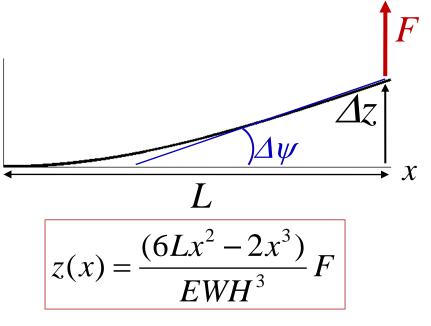
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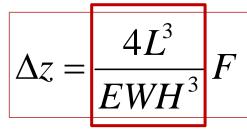
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Angle at x = L for optical lever detection

$$\Delta \psi = \frac{\partial z}{\partial x} \Big|_L$$

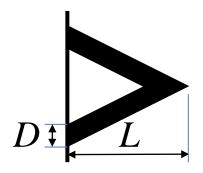
$$\frac{\Delta z}{\Delta \psi} = \frac{2L}{3} = cL$$

Theoretical stiffness from Euler-Bernoulli model

Rectangular cantilever

$$k_0 = \frac{EWH^3}{4L^3}$$

□ V-shaped cantilever



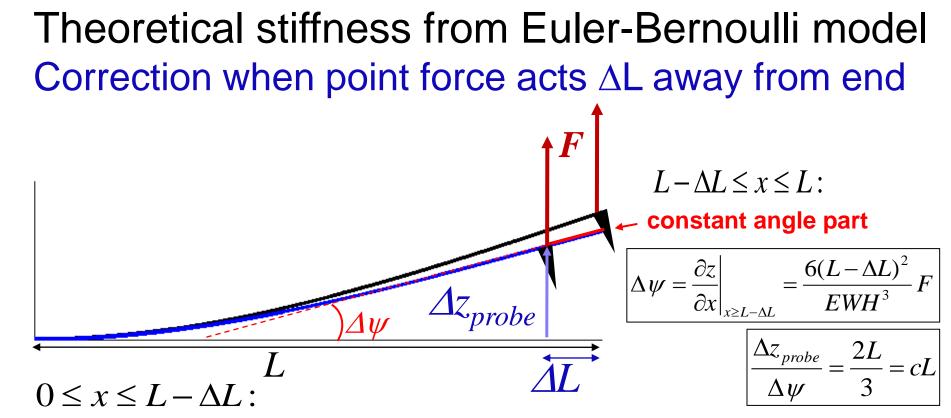
- no exact analytical expression
- > approximate expression:

Sader, Rev. Sci. Instrum. 66, 4583 (1995)

$$k_0 = \frac{EDH^3}{2L^3} \times \text{geometrical correction}$$

Parallel beams approximation

Expressions used by manufactors for cantilever stiffness estimation Main error sources: thickness *H* (to the power 3), and Young modulus *E*



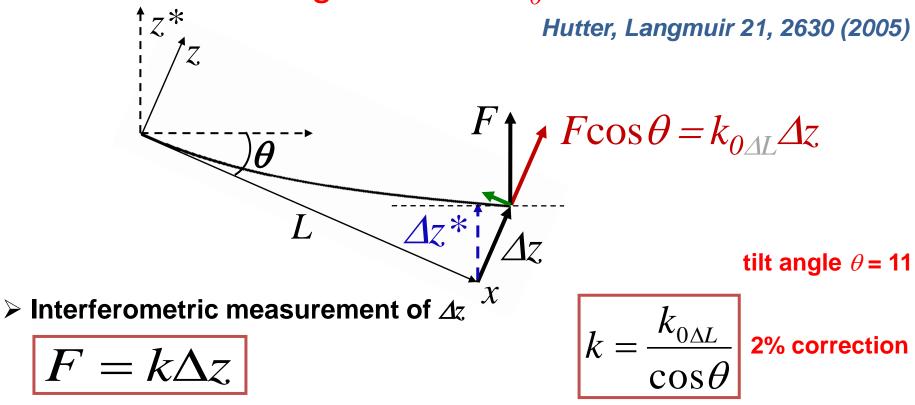
As if beam length was L- ΔL instead of L

$$z(x) = \frac{(6(L - \Delta L)x^2 - 2x^3)}{EWH^3}F$$
$$\Delta z_{probe} = z(L - \Delta L) = \frac{4(L - \Delta L)^3}{EWH^3}F$$
$$\frac{1/k_{0\Delta L}}{EWH^3}$$

$$k_{0\Delta L} = k_0 \left(\frac{L}{L - \Delta L}\right)^3$$

 $L = 300 \ \mu\text{m}, \ \Delta L = 10 \ \mu\text{m}$ $\rightarrow 10\%$ correction

Theoretical stiffness from Euler-Bernoulli model Influence of tilt angle θ : from k_0 to k and k*



> Optical lever with 4-quadrant photodiodes

$$F = k^* s \Delta V$$

$$s\Delta V = \Delta z^* = \Delta z \cos \theta$$

$$k^* = \frac{k}{\cos\theta} = \frac{k_{0\Delta L}}{\cos^2\theta}$$

4% correction

s calibrated from slope of ΔV versus Δz^* when pushing on hard surface

Theoretical stiffness from Euler-Bernoulli model Influence of tilt angle θ : torque correction Hutter, Langmuir 21, 2630 (2005); Edwards et al., J. Appl. Phys. 103, 064513 (2008) Static deformations with boundary conditions $3F\cos\theta$ $\frac{k_0 L^3}{k_0 L^3}$ $\left| z(x=0) = \frac{\partial z}{\partial x} \right|_{x=0} = 0 \quad \text{; At } x=L: \text{ point force}$ $\overline{\partial x^3}$ At *x*=0: clamped and point torque $\partial^2 z$ $3DF\sin\theta$ $\overline{\partial x^2}$ $k_0 L^3$ Tip of height DSphere of radius *R*: replace D by R $\frac{1}{3D}\tan\theta$ $F = \frac{k_0}{\cos\theta}$ $\frac{(3L(1-\frac{D}{L}\tan\theta)x^2 - x^3)}{2k_0L^3}F\cos\theta$ Δz z(x) =**Torque correction** $1-3D\tan\theta/2L$ 2L $L = 300 \ \mu\text{m}, D=10 \ \mu\text{m}, \text{ tilt angle } \theta = 11$ = cL $1-2D\tan\theta/L$ 3 $\Delta \psi$ \rightarrow 1% correction on k

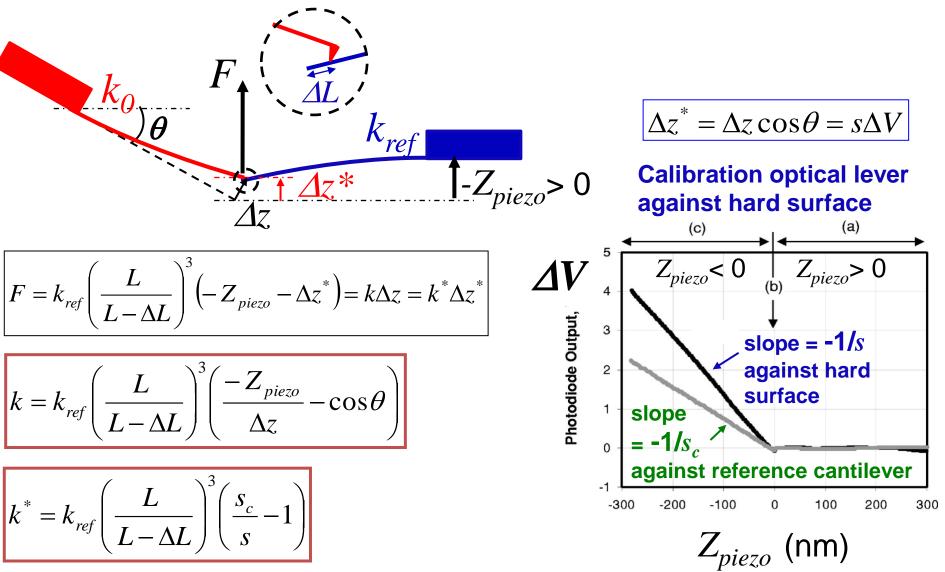
 \rightarrow 0.3% correction on $\Delta \varphi I \Delta z$

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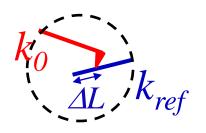
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Calibration using static deformations: Cantilever against reference cantilever method



Gates et al., Rev. Sci. Instrum, 78, 086101(2007)

Calibration using static deformations: Cantilever against reference cantilever method



Avantages:

> works for all type of cantilevers and probes

 \succ direct measure of k and k*, ie stiffness of

interest in experimental configuration

Drawbacks:

- > requires reference cantilever with $k_{ref} \sim k_0$
- requires mechanical contact (risk of damaging the probe)
- \succ sensitive to position ΔL of the probe on the reference cantilever

Main error sources: measurement of slope(s) (because of solid friction), and position ΔL

Introduction

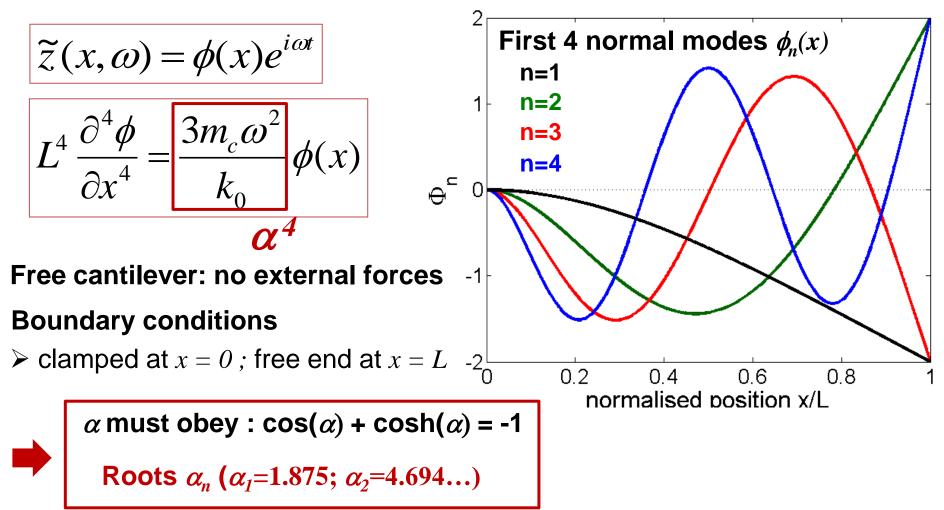
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Calibrations based on modes of oscillation: Normal modes in Euler-Bernoulli model



Normal spatial modes $\phi_n(x, \alpha_n)$ form a basis set of fonctions in [0,L]

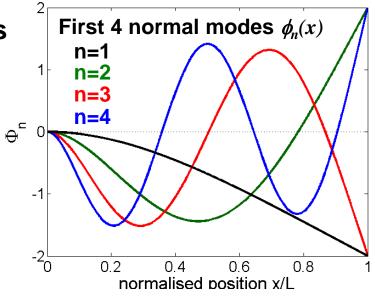
Butt et al., Nanotechnol. 6, 1 (1995)

Calibrations based on modes of oscillation: : From normal modes to simple harmonic oscillators

Decomposition on basis of normal modes

$$\widetilde{z}(x,\omega) = \sum_{n} \widetilde{Z}_{n}(\omega)\phi_{n}(x)$$
$$\widetilde{f}_{ext}(x,\omega) = \frac{1}{L}\sum_{n} \widetilde{\beta}_{ext,n}(\omega)\phi_{n}(x)$$

$$\left(\frac{\alpha_n^4 k_0}{3} - \omega^2 m_c\right) \widetilde{Z}_n(\omega) = \widetilde{\beta}_{ext,n}(\omega)$$

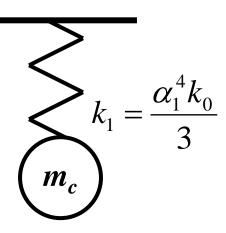


Each mode of oscillation behaves as a simple harmonic oscillator (SHO) with

stiffness
$$k_n = \frac{\alpha_n^4 k_0}{3}$$

mass m_c k_n

Calibrations based on modes of oscillation: Simple harmonic oscillator (SHO) method



> Measure angular frequency ω_1 of 1st resonance

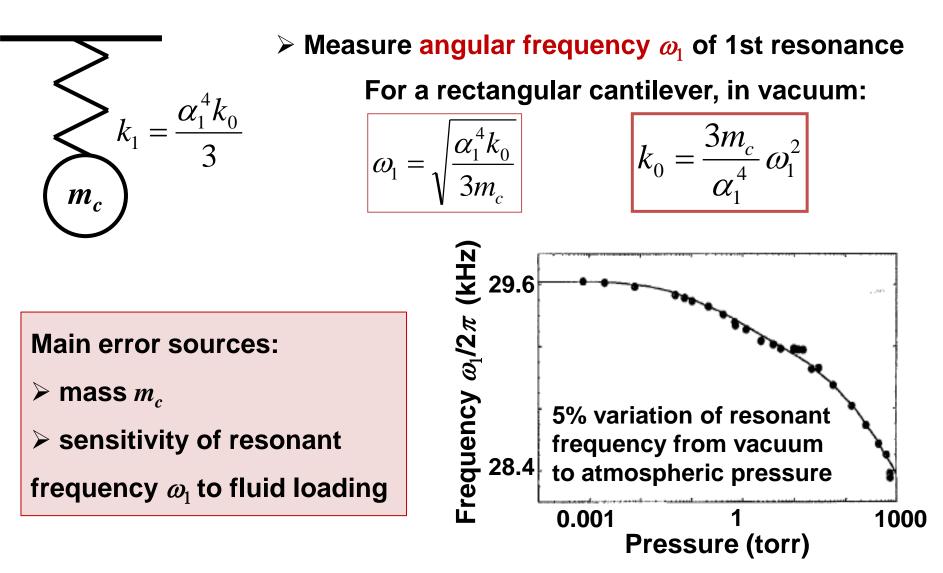
For a rectangular cantilever, in vacuum:

$$\omega_1 = \sqrt{\frac{\alpha_1^4 k_0}{3m_c}}$$

$$k_0 = \frac{3m_c}{\alpha_1^4}\omega_1^2$$

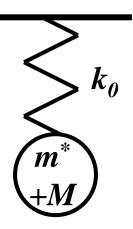
Sader et al., Rev. Sci. Instrum. 66, 3789 (1995)

Calibrations based on modes of oscillation: Simple harmonic oscillator (SHO) method



Sader et al., Rev. Sci. Instrum. 66, 3789 (1995)

Calibrations based on modes of oscillation: Cleveland's added mass method

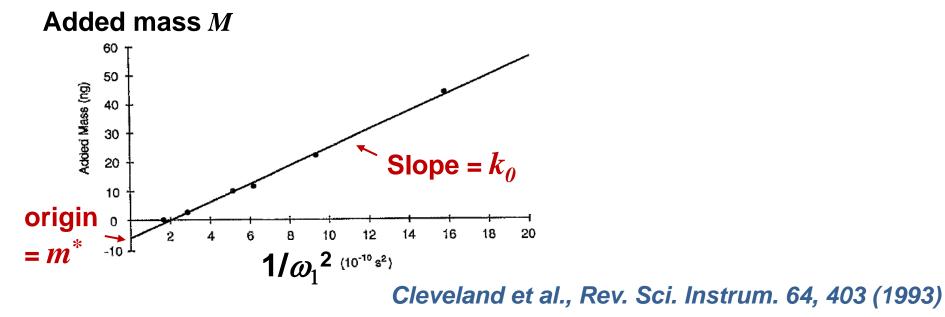


- > Attach spheres of mass *M* at the end of the cantilever
- > Measure angular frequency ω_1 of 1st résonance

$$\omega_1 = \sqrt{\frac{k_0}{m^* + M}}$$

For a rectangular cantilever: $m^* = \frac{3m_c}{\alpha_1^4} = 0.24m_c$

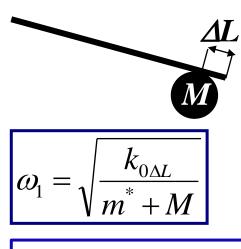
> Plot *M* as a function of $1/\omega_1^2$



Calibrations based on modes of oscillation: Cleveland's added mass method

Cleveland et al., Rev. Sci. Instrum. 64, 403 (1993)

Evaluated in: Sader et al., Rev. Sci. Instrum. 66, 3789 (1995)



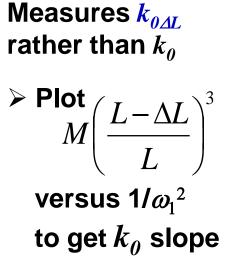
Avantages:

- > works for all type of cantilevers and probes
- independant of type and calibration of detection
- > insensitive to fluid-loading effects when $M > 10 m_c$

Drawbacks:

- requires micromanipulations
- > post-mortem due to risk of damaging the probe
- \succ sensitive to position ΔL of the added mass

Main error sources: mass M, and position ΔL



Calibrations based on modes of oscillation: Sader model for hydrodynamic load

When a cantilever is immersed in a fluid (viscosity η_f and density ρ_f)

- > broadening of resonance due to viscous damping
- > diminution of resonant frequency due to added mass by the fluid

Calibrations based on modes of oscillation: Sader model for hydrodynamic load

When a cantilever is immersed in a fluid (viscosity η_f and density ρ_f)

- broadening of resonance due to viscous damping
- Image: A standard descent for the standard descent and the standard descent for the standard

Hydrodynamic load

$$\widetilde{f}_{hydro}(x,\omega) = \frac{\pi}{4} \rho_f \omega^2 W^2 \widetilde{\Gamma}(\frac{\rho_f W^2 \omega}{4\eta_f}) \widetilde{z}(\omega,x)$$
Hydrodynamic function $\widetilde{\Gamma}$ computed
for low-order modes of oscillation of
rectangular cantilever with $T << W << L$

$$\overline{W} \stackrel{\uparrow}{\longrightarrow} \widetilde{z}(x,\omega)$$
Sader, J. Appl. Phys 84, 64 (1998)
Sader et al., J. Appl. Phys 97, 124903 (2005)
$$\overset{100}{\longrightarrow} \widetilde{z}(\omega,x)$$

$$\overset{100}{\longrightarrow} \widetilde{u}$$

$$\overset{100}{\longleftarrow} \widetilde{u}$$

Calibrations based on modes of oscillation: Sader model for hydrodynamic load

Decomposition on basis of normal modes of oscillation

$$\underbrace{\begin{pmatrix} k_n - \omega^2 m_c \left(1 + \tilde{\tau}_r(\omega)\right) - i\omega \left(m_c \omega \tilde{\tau}_i(\omega)\right) \end{pmatrix}}_{\boldsymbol{w}_{eff}(\boldsymbol{\omega})} \widetilde{\boldsymbol{v}_{eff}(\boldsymbol{\omega})} \text{ with } \widetilde{\boldsymbol{\tau}}_r(\omega) + i\tilde{\boldsymbol{\tau}}_i(\omega) = \frac{\pi}{4} \frac{\rho_f L W^2}{m_c} \widetilde{\boldsymbol{\Gamma}}(\frac{\rho_f \omega}{4\eta_f})$$

Low damping limit (quality factor $Q \ge 10$): $m_{eff}(\omega)$ and $\gamma_{eff}(\omega) \sim \text{constant arount resonance peak}$

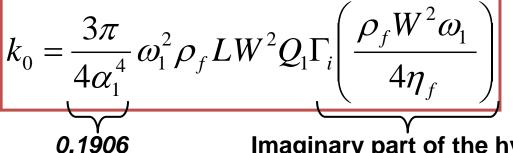
Each mode of oscillation behaves as a damped SHO with:

stiffness
$$k_n = \frac{\alpha_n^4 k_0}{3}$$

mass $m_{eff,n} = m_c (1 + \tau_r(\omega_n))$
damping $\gamma_{eff,n} = m_c \omega_n \tau_i(\omega_n)$
 $\left[\begin{array}{c} \omega_n = \sqrt{\frac{k_n}{m_{eff,n}}} \\ Q_n = \frac{k_n}{\omega_n \gamma_{eff,n}} = \frac{1 + \tau_r(\omega_n)}{\tau_i(\omega_n)} \end{array} \right]$

Calibrations based on modes of oscillation: Hydrodynamic Sader method

Rectangular cantilever, low damping limit (quality factor $Q_1 \ge 10$):



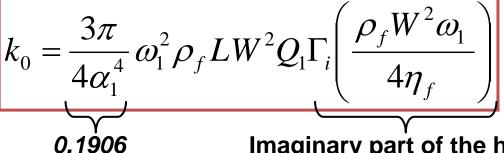
Sader et al., Rev. Sci. Instrum. 70, 3967 (1999)

Imaginary part of the hydrodynamic function

- $\succ \eta_f$ and ρ_f tabulated
- L and W measured by optical microscopy
- $\succ \omega_1$ and Q_1 measured from damped SHO fit of 1st resonance peak

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Avantages:

➢ fast, precise, easy -- online calibration on:

http://www.ampc.ms.unimelb.edu.au/afm/theory.html

independant of type and calibration of detection

Underestimates k_0 if presence of colloidal probe of diameter > W/2

Main error sources: width W_{2} , and quality factor Q_{1}

Calibrations based on modes of oscillation: Equipartition of energy and thermal noise PSD

Small dissipation (high *Q*):

Modes of oscillation Z_n are independent degrees of freedom

$$\frac{1}{2}k_n \left\langle Z_n^2 \right\rangle = \frac{1}{2}k_B T$$

Total thermal noise of the cantilever

$$\left\langle \Delta z^2 \right\rangle = \sum_n \left\langle Z_n^2 \right\rangle \left| \phi_n (x = L) \right|^2 = \frac{k_B T}{k_0} \sum_n \frac{12}{\alpha_n^4} = \frac{k_B T}{k_0}$$

Link with thermal noise PSD of the cantilever:

$$\left\langle \Delta z^2 \right\rangle = \int_0^\infty S_{thermal}^{\Delta z}(f) df = \int_0^\infty (S_{measured}^{\Delta z} - S_{background}^{\Delta z}) df$$

Butt et al., Nanotechnol. 6, 1 (1995)

Calibrations based on modes of oscillation: Equipartition of energy and thermal noise PSD

For detection with optical lever: total thermal noise of ΔV

$$\left\langle \Delta V^2 \right\rangle = \left(cL \frac{\cos\theta}{s} \right)^2 \left\langle \Delta \psi^2 \right\rangle = \left(cL \frac{\cos\theta}{s} \right)^2 \sum_n \left\langle Z_n^2 \right\rangle \left| \frac{\partial \Phi_n}{\partial x} \right|_L^2 = 12c^2 \frac{\cos^2\theta}{s^2} \frac{k_B T}{k_0} \sum_n \frac{1}{\alpha_n^2} \left(\frac{\sin\alpha_n \sinh\alpha_n}{\sin\alpha_n + \sinh\alpha_n} \right)^2 \right\rangle$$

thermal poise of angular deflexion

thermal noise of angular deflexion

$$\left< \Delta V^2 \right> \approx \frac{4}{3} \frac{\cos^2 \theta}{s^2} \frac{k_B T}{k_0}$$

Butt et al., Nanotechnol. 6, 1 (1995)

Hutter, Langmuir 21, 2630 (2005)

Link with thermal noise PSD of signal ΔV :

$$\left\langle \Delta V^2 \right\rangle = \int_0^\infty S_{thermal}^{\Delta V}(f) df = \int_0^\infty (S_{measured}^{\Delta V} - S_{background}^{\Delta V}) df$$

Calibrations based on modes of oscillation: Thermal noise calibration

Hutter et al., Rev. Sci. Instrum. 64, 1868 (1993)

Idea:

measure k_0 from integration of thermal noise PSD

but in reality, finite integration range: thermal noise PSD only available around resonance because of background noise

So no direct access to mean square amplitudes $\left<\Delta V^2\right>$ and $\left<\Delta z^2\right>$

Calibrations based on modes of oscillation: Thermal noise calibration

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Contribution of mode n to total thermal noise ?

Fluctuation dissipation theorem on amplitude of normal mode n

$$\frac{\left\langle \left| \widetilde{Z}_{n}(\omega) \right|^{2} \right\rangle}{\Delta f} = -\frac{4k_{B}T}{\omega} \operatorname{Im} \left(\frac{\widetilde{Z}_{n}(\omega)}{\widetilde{\beta}_{ext,n}(\omega)} \right) = \frac{k_{B}T}{k_{n}} \frac{4/\omega_{n}Q_{n}}{\left(1 - \left(\frac{\omega}{\omega_{n}} \right)^{2} \right)^{2} + \frac{1}{Q_{n}^{2}} \left(\frac{\omega}{\omega_{n}} \right)^{2}}$$

$$\omega_n = \sqrt{\frac{k_n}{m_{eff,n}}}$$
$$Q_n = \frac{k_n}{k_n}$$

 $\omega_n \gamma_{eff,n}$

Calibrations based on modes of oscillation: Thermal noise calibration

SHO fit of resonance peak in thermal noise PSD of free cantilever:

Hutter, Langmuir 21, 2630 (2005)

Error sources: error on fit parameters + error on *s* if optical lever technique

Conclusion

Comparison of calibration methods for cantilever's bending stiffness k_0

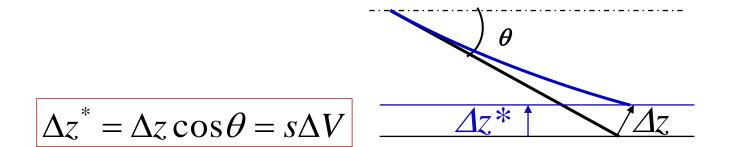
	Theoretical	SHO	Added mass	Hydro Sader	Thermal noise	Cant. against reference cant.
requires	L,W, H, E	$m_c \omega_1$	$M, \Delta L \\ \omega_1$	η_{f} , $ ho_{f}$ $L, W,$ ω_{1} , Q_{1}	T, thermal noise PSD + s, θ for optical lever	+ slopes $\Delta signal / Z_{piezo}$
Main error sources	H, E	$m_c \ \omega_1$ in fluid	Μ, ΔL	<i>W</i> , <i>Q</i> ₁	SHO fit, s	k_{ref} , ΔL + slopes $\Delta signal / Z_{piezo}$ in contact
Typical uncertainty	30-50 % can be re by MEB p to meas	pictures	10-30 %	5-10 %	5 -10 %	10-30 %

Conclusion: to go further...

> Other calibration methods for cantilever's bending stiffness k_0 and variants...

For example:

- mapping of spatial modes along the cantilever from thermal noise Paolino et al., J. Appl. Phys. 106, 094313 (2009) and HDR of L. Bellon
- calibration using electrostatic forces on metal-coated colloidal probes Chung et al., Rev. Sci. Instrum. 80, 065107 (2009)
- Influence of the position of the laser beam on the cantilever on the effective stiffness k and k* : mode dependent correction factor In this course, laser beam assumed focused on point of application of the force
- Calibration of torsional spring constant for lateral force measurement For example: Green et al., Rev. Sci. Instrum. 75, 1988 (2004)



$$\left. \frac{\partial z}{\partial x} \right|_{L} = \frac{3}{2L} \Delta z$$

$$\left|\frac{\partial \Phi_n}{\partial x}\right|_L^2 = \frac{4\alpha_n^2}{L^2} \left(\frac{\sin \alpha_n \sinh \alpha_n}{\sin \alpha_n + \sinh \alpha_n}\right)^2$$